

<b>Notice of References Cited</b>	Application/Control No. 10/564,055	Applicant(s)/Patent Under Reexamination MAKINO ET AL.	
	Examiner KIM CHU	Art Unit 2627	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,227,071	06-2007	Tagawa et al.	84/601
*	B	US-7,149,961	12-2006	Harville et al.	715/202
*	C	US-2002/0041692	04-2002	Seto et al.	381/86
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**NON-PATENT DOCUMENTS**

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